



AF/2811

Corres. and Mail
BOX AF

PATENT

Docket No.: 57454-162

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: **RESPONSE UNDER 37 CFR 1.116**

Yukio MAKI

: **EXPEDITED PROCEDURE**

Serial No.: 09/909,975

: Group Art Unit: 2811

Filed: July 23, 2001

: Examiner: S. Gebremariam

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD OF THE SAME

#12/Amendt A...
3/18/03
Enter...
4/22/03

AMENDMENT UNDER 37 CFR §1.116

Box AF
Commissioner for Patents
Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated December 12, 2002, pursuant to the provisions of 37 C.F.R. §1.116.

RECEIVED
MAR 14 2003
TECHNOLOGY CENTER 2800

IN THE CLAIMS:

Please amend claim 1 as follows.

1. (Amended) A semiconductor device, comprising:

a semiconductor substrate including an active region and an isolation region; and

a gate electrode formed on said active region with an insulating film interposed

therebetween, wherein:

a surface of said active region is entirely rounded so as to be inclined downward toward

said isolation region;

said semiconductor device includes an SRAM (Static Random Access Memory);